

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	4661	semiconductor and ((cool or cooling or coolant) same (adher\$3 or adhesive or stick or sticking))	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/10/14 16:23
L2	2035	semiconductor and ((cool or cooling or coolant) with (adher\$3 or adhesive or stick or sticking))	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/10/14 16:23
L3	787	2 and (clean or cleaning or residue or contaminant)	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/10/14 16:23
L4	331	3 and @ay<="1998"	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/10/14 16:23
L5	308	4 and (heat or heating or bake or baking)	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/10/14 16:24
L6	70	5 and plasma	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/10/14 17:47
L7	179	438/709.ccls.	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/10/14 17:47
L8	1292	438/710.ccls.	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/10/14 17:47
L9	2921	438/714.ccls.	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/10/14 17:48
L10	282	438/715.ccls.	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/10/14 17:48
L11	1002	438/723.ccls.	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/10/14 17:48
L12	152	438/716.ccls.	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/10/14 17:49
L13	372	438/743.ccls.	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/10/14 17:51
L14	692	Kobayashi-Yasuo.in.	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/10/14 17:51
S1	1	"5350480".pn.	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/10/13 17:17
S2	39	("5350480").URPN.	USPAT	OR	ON	2005/10/13 17:31

S3	8762	semiconductor and ((cool or cooling) same (clean or cleaning or treatment))	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/10/13 18:17
S4	2929	S3 and plasma	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/10/13 17:32
S5	2707	S4 and (heat or heating or heated)	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/10/13 17:32
S6	2730	S4 and (heat or heating or heated or heater)	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/10/13 17:32
S7	3186314	"14" and @ay<="1998"	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/10/13 17:33
S8	881	S6 and @ay<="1998"	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/10/13 17:33
S9	522	S8 and (hydrogen or "H.sub.2")	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/10/13 17:33
S10	184	S9 and (Uv or ultra\$1violet or DUv)	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/10/13 18:18
S11	3826	semiconductor and ((cool or cooling) same (clean or cleaning))	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/10/13 18:17
S12	783	S11 and (Uv or ultra\$1violet or DUv)	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/10/13 18:18
S13	262	S12 and @ay<="1998"	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/10/13 18:18
S14	176	S13 not S10	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/10/13 18:18
S15	64	S14 and (hydrogen or "H.sub.2" or (reduc\$3 adj gas))	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/10/13 18:19
S16	64	S14 and (hydrogen or "H.sub.2" or (reduc\$3 adj (gas or agent)))	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/10/13 18:19
S17	2	("5032462" "6144491").PN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/10/13 18:24
S18	5	("4268374" "4615756" "4871416" "5089084" "5089441").PN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/10/13 18:34

S19	24	("5326406").URPN.	USPAT	OR	ON	2005/10/13 18:35
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